	Application No.	Applicant(s)	
Notice of Allowability	10/677,154	CAPODIECI, LUIGI	
	Examiner	Art Unit	
	Naum B. Levin	2825	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT IN of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in i) or other appropriate commu RIGHTS. This application is s	this application. If not include inication will be mailed in due	ed course. THIS
1. This communication is responsive to <u>Amendment 08/01/0</u>	<u>95</u> .		
2. The allowed claim(s) is/are <u>1,3-15 and 17-24</u> .			
3.			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Info	ormal Patent Application (PTC	D-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🔲 Interview Su	6. Interview Summary (PTO-413),	- · ,
Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date	Paper No./N 08), 7. ☐ Examiner's A	Paper No./Mail Date 7.	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's S	Statement of Reasons for Allo	wance

9. Other ____.

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DETAILED ACTION

1. This office action is in response to application 10/677,154 and Amendment filed on 08/01/2005. Claims 1 and 15 have been amended by including additional limitations. Claims 2 and 16 have been canceled, claims 23-24 are newly added.

Claims 1, 3-15 and 17-24 remain pending in the application.

Allowable Subject Matter

- 2. Claims 1, 3-15 and 17-24 are allowed over prior art of record.
- 3. The following is an examiner's statement of reasons for allowance:

The prior art of record fails to teach or suggest or render obvious:

A method for making optical proximity corrections to a reticle layout topology, comprising generating a plurality of individual figure of merit values each of which are associated with the corrected reticle layout and correspond to a different process metric, generating a generalized figure of merit (GFOM) using the plurality of individual figure of merit values, and manipulating the edge segments of the corrected reticle layout to arrive at a revised corrected reticle layout using OPC guided by the GFOM as a convergence benchmark that indicates a degree of optimization of local critical dimension (CD) accuracy.

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Naum B. Levin whose telephone number is 571-272-1898. The examiner can normally be reached on M-F (8:00-4:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

NL

MAT THEW SMITH
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800